State of Oregon
Department of
Environmental
Quality

Notification of Compliance Status
National Emission Standards for Hazardous Air Pollutants
For Paint and Allied Products Area Sources
40 CFR Part 63 Subpart CCCCCCC

1. Company Information:

Legal Name:	Facility name (if different than legal name):
Mailing address:	Facility address (if different than mailing address):
City, state, zip code:	City, state, zip code:
Source category/NAICS code:	Source ID:

2. Site Contact Person:

Name:	Telephone number:
Title:	Email address:

3. Appropriate compliance date and notification of compliance status due dates for the facility:

Type of Affected Source	Compliance Date	Date NOCS is Due
☐ Existing Source	December 3, 2012	June 3, 2013
☐ New Source	New affected sources that started up on or before December 3, 2009: December 3, 2009 New affected sources that started up after December 3, 2009: Upon startup of affected source Specify startup date:_____	New affected sources that started up on or before December 3, 2009: June 1, 2010 New affected sources that started up after December 3, 2009: 180 days after startup of affected source

4. HAP emissions (reported in units and averaging times and in accordance with the test methods specified in the standards):

HAP	Emissions	Units	Averaging Times

5. Affected emission sources and compliance approaches:

☐	Addition of dry pigments and solids containing metal HAPs to process vessel	☐	Operate capture system and route particulate emissions to particulate control device that minimizes fugitive emissions. Control device type ____ (wet or dry).
		☐	Add pigments and other solids in paste slurry or other liquid form
☐	Addition of dry pigments and solids containing metal HAPs to grinding and milling process	☐	Operate capture system and route particulate emissions to particulate control device that minimizes fugitive emissions. Control device type ____ (wet or dry).
		☐	Add pigments and other solids in paste slurry or other liquid form.
☐	Grinding and milling of materials containing metal HAPs	☐	Operate capture system and route particulate emissions to particulate control device that minimizes fugitive emissions. Control device type ____ (wet or dry).
		☐	Fully enclose the grinding and milling equipment.
		☐	Ensure that pigments and solids are in the solution during grinding and milling.
☐	Process and storage vessels that store or process materials containing benzene or methylene chloride	☐	Equip with cover or lid that: does not warp or move around during the manufacturing process; maintains contact along at least 90-percent of the vessel rim; and that is maintained in good condition.
☐	Mixing vessels that store or process materials containing benzene or methylene chloride	☐	Equip with cover that completely covers the vessel, except as necessary to allow for safe clearance of the mixer shaft.
☐	Leaks and spills of materials containing benzene or methylene chloride	☐	Minimize and clean up as soon as practical, but no longer than 1 hour from the time of detection.
☐	Rags or other material containing benzene or methylene chloride	☐	Keep in a closed container that may contain a device that allows pressure relief, but does not allow liquid solvent to drain from the container.

6. If complying with the NESHAP using a particulate control device, include the information related to the initial control device inspections and tests.

Emission Source	Control Device	Water Flow Verified (Wet Scrubbers Only)	Ductwork/Control Device Inspected	Visible Emission Test Performed	Emissions < 10% Opacity
					☐
					☐
					☐

7. Compliance Certification

I certify that to the best of my knowledge my facility has complied with all the relevant standards and other requirements of 40 CFR Part 63 Subpart CCCCCCC.

Signature:	Date:
Name:	Telephone Number:
Title:	Email Address: